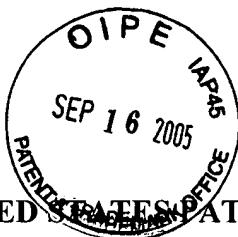


IFW

Docket No.: 060188-0865



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Masahiro OGAWA : Confirmation Number: 6747
Application No.: 10/849,053 : Group Art Unit: 2826
Filed: May 20, 2004 : Examiner: MONDT, JOHANNES P.
For: SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of August 24, 2005 wherein restriction has been required, Applicant hereby elects Group I (claims 1-2) for prosecution in the above-identified application. To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogarty
Registration No. 36,139
Please recognize our Customer No. 20277
as our correspondence address.

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Date: September 16, 2005